

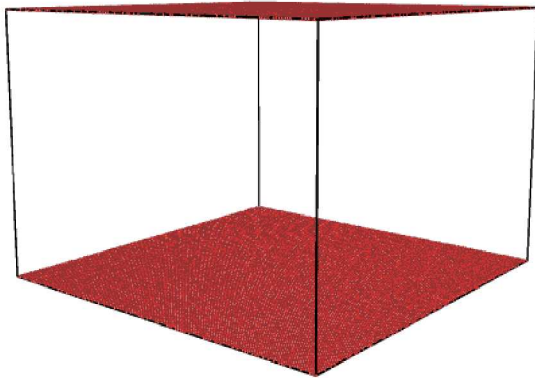
## In-Situ Characterization of Single Ion Strikes in Single Crystal Silicon

**Anthony M. Monterrosa, James Stewart, Patrick Price, Remi Dingreville, Khalid Hattar**

Fall MRS 2018

November 29<sup>th</sup>, 2018

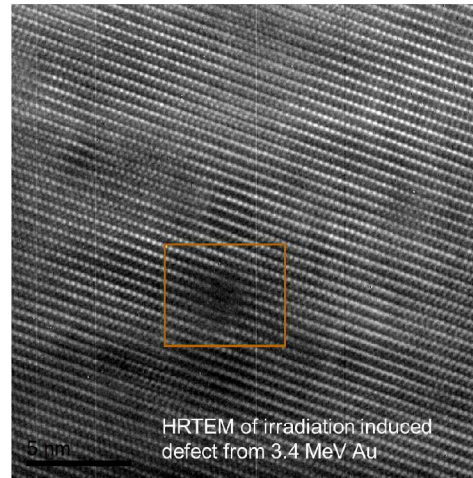
# Temporal Gap Between Modeling and Experiments



## **Molecular Dynamics Modeling of Cascades:**

**Temporal Resolution:**  $<$  picoseconds

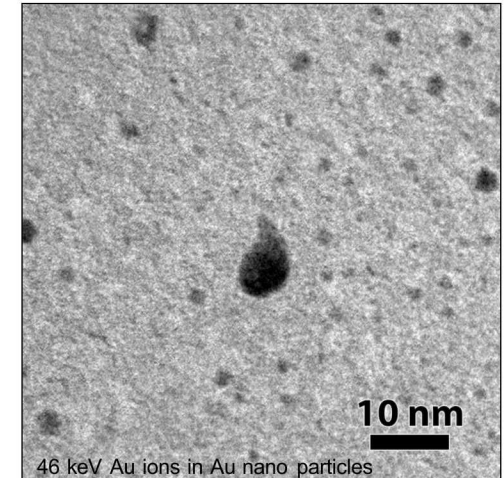
**Spatial Resolution:** single atoms



## **Experimental Observations of Radiation Damage:**

**Temporal Resolution:**  $1/30^{\text{th}}$  of a second (standard camera)

**Spatial Resolution:** single atoms

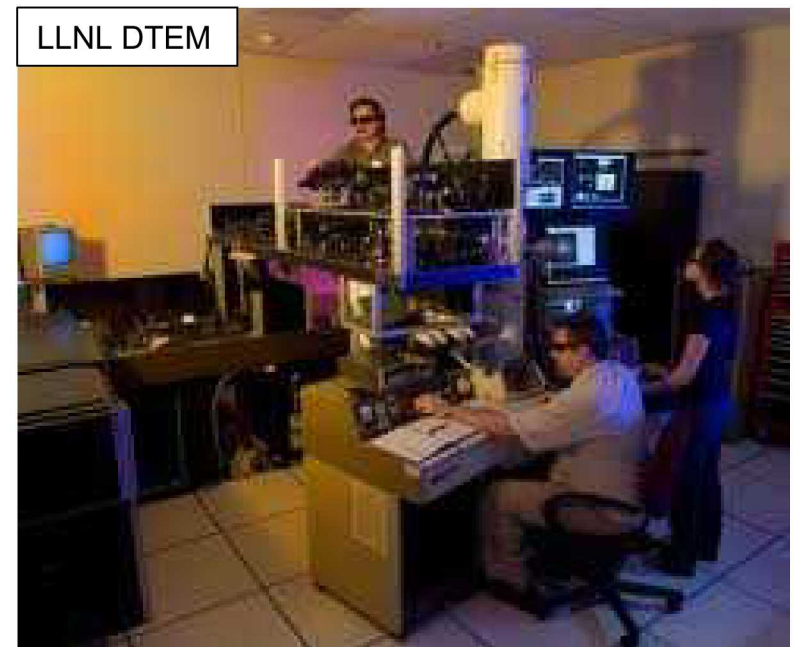


**Computational models can be scaled up but is expensive and requires multidimensional physics.**

**Advances in experimental capabilities can be used to approach the scale of computational models.**

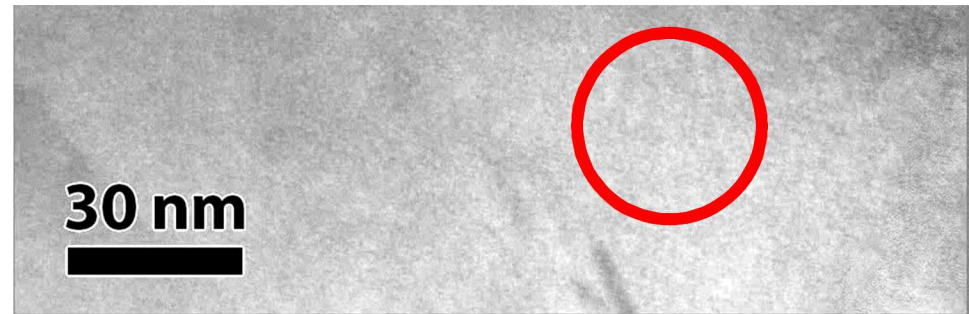
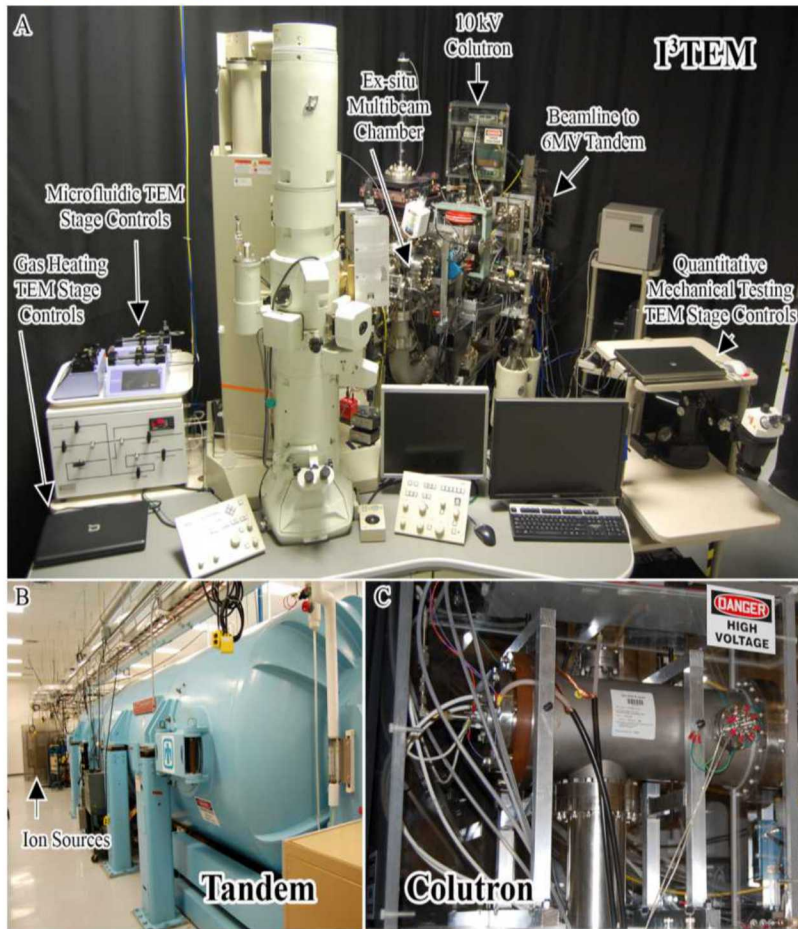
# Objective

Discuss the development of **high spatial and temporal resolution microscopy** techniques that allow for characterization of **single ion strikes**.





# Sandia's In-Situ Ion Irradiation Transmission Electron Microscope (I<sup>3</sup>TEM)



- 1.7 MeV Au into single crystal Si
- Single ion strikes can be observed in semiconductors
- Non-symmetric structure in contrast to the spherical approximation

Can we go beyond this to observe:

- the important aspects of structural evolution as a function of time (ns to hrs.)?
- the evolution in more complex systems (GaAs)?
- Directly correlate it to key model parameters?

Hattar, K., D. C. Bufford, & D. L. Buller. "Concurrent in situ ion irradiation transmission electron microscope." *NIM:B* **338**, 56-65 (2014).

# Single Ion Strikes Explored with Molecular Dynamics

INITIATION

PEAK DAMAGE

DEFECT RECOMBINATION

time  $\approx 0.023$  ps

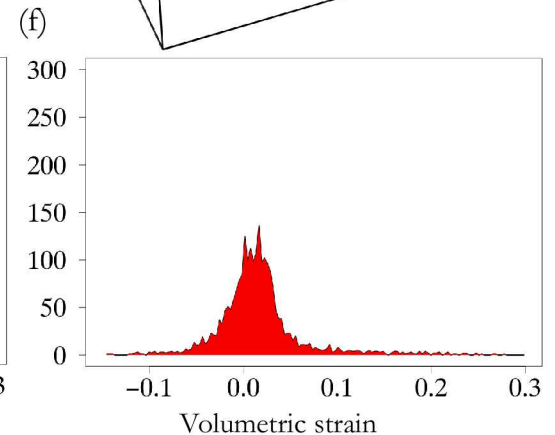
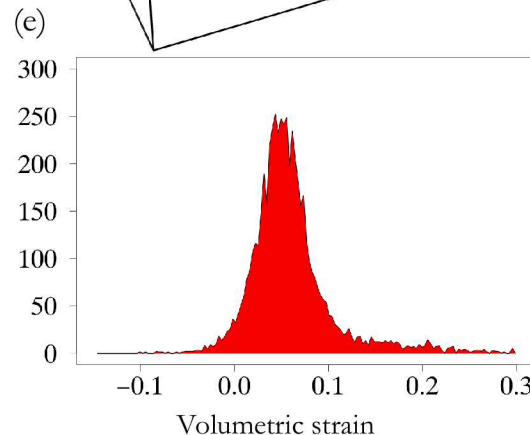
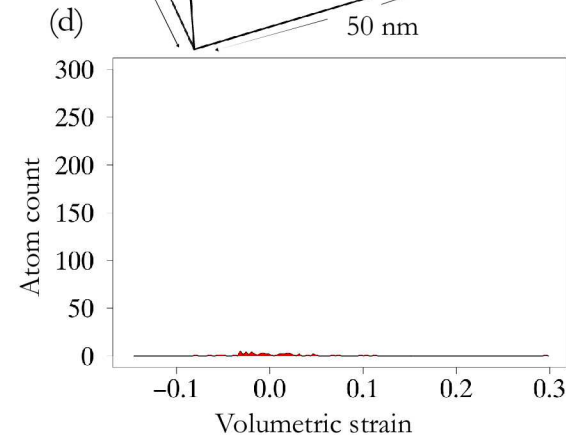
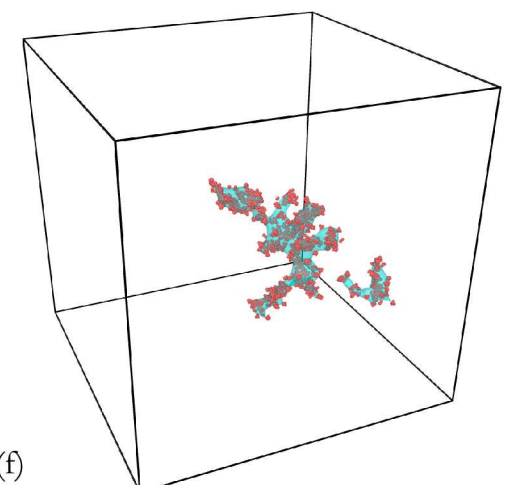
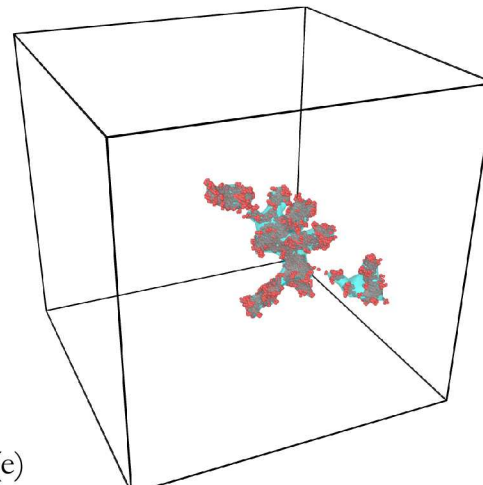
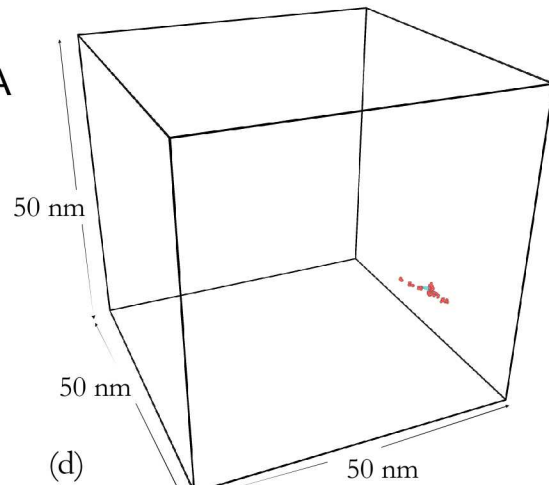
time  $\approx 0.273$  ps

time  $\approx 73.773$  ps

(a)

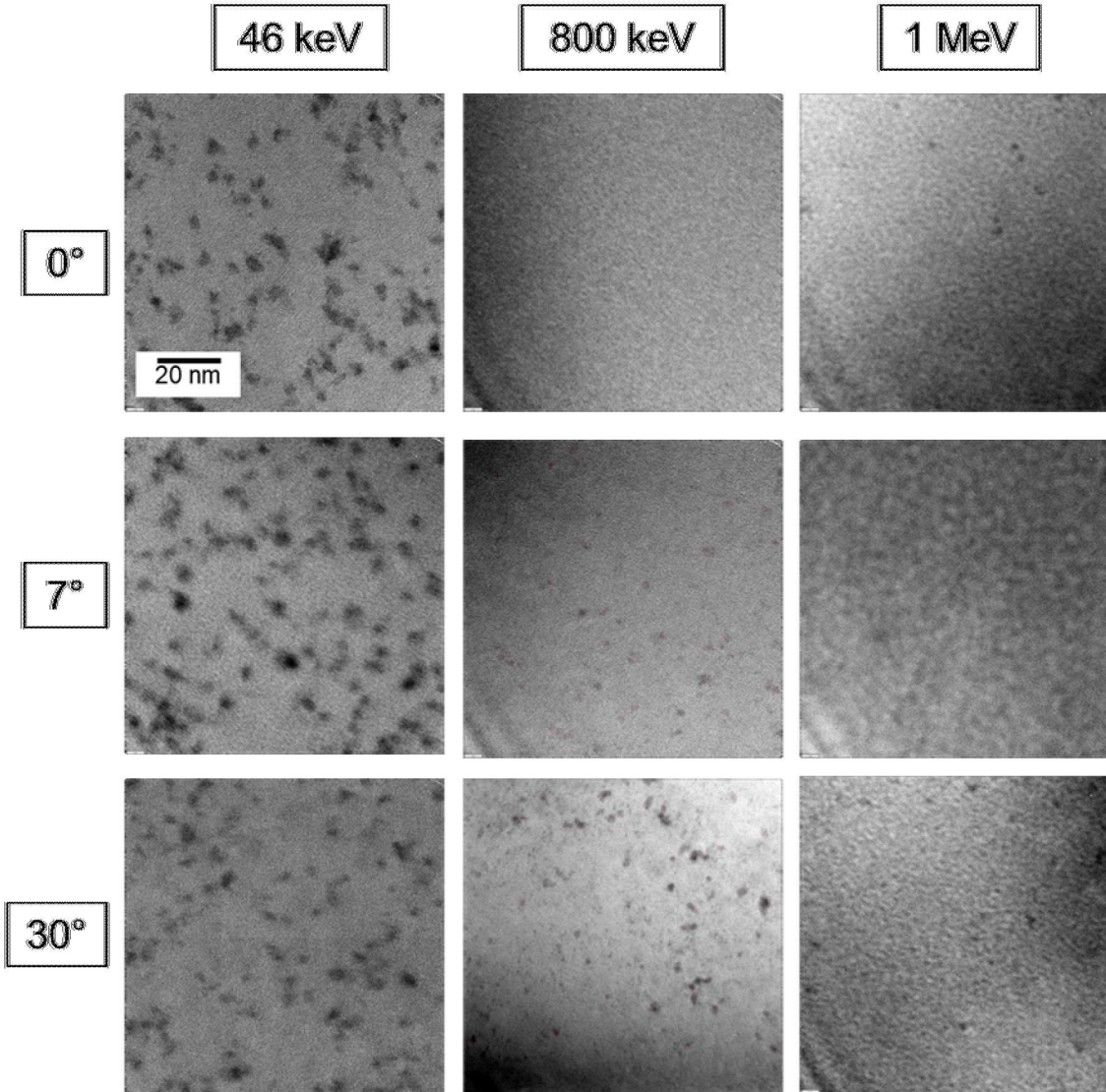
(b)

(c)



[Stewart et al. (2018) *J. Appl. Phys.*]

# Black Dot Damage Distributions



Single crystal  $\langle 001 \rangle$  Si irradiated ex-situ with Au ions at a variety of energies and angles of incidence.

Probing the damage cascade experimentally is limited to contrast from black-dot damage.

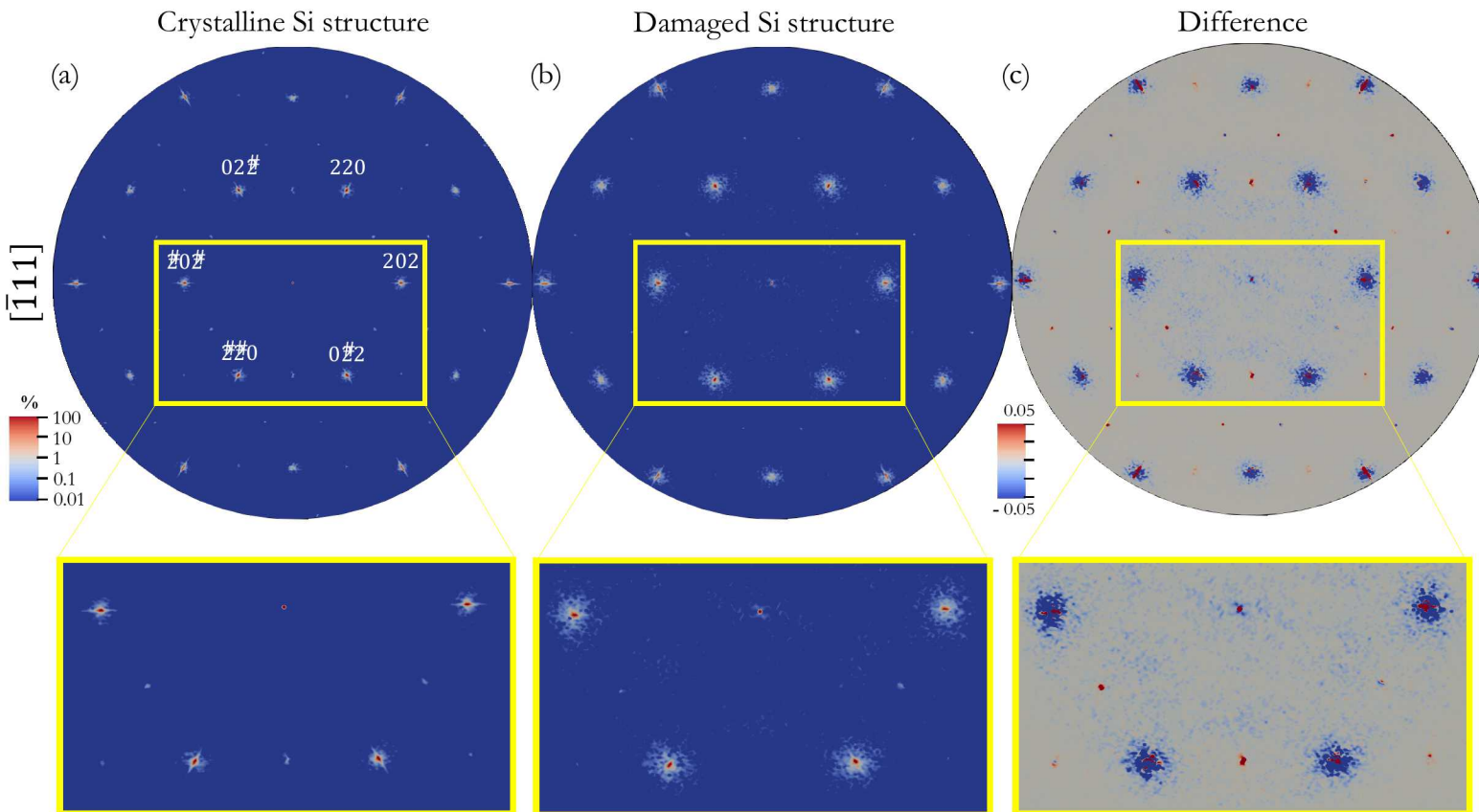
Can a coupling of modeling and experiment be used to:

- Obtain defect distributions represented in real-space images?
- Directly correlate quantitative experimental results with modeling results?
- Account for contrast variation seen in TEM?



# Using Diffraction to Compare Modeling and Experiments

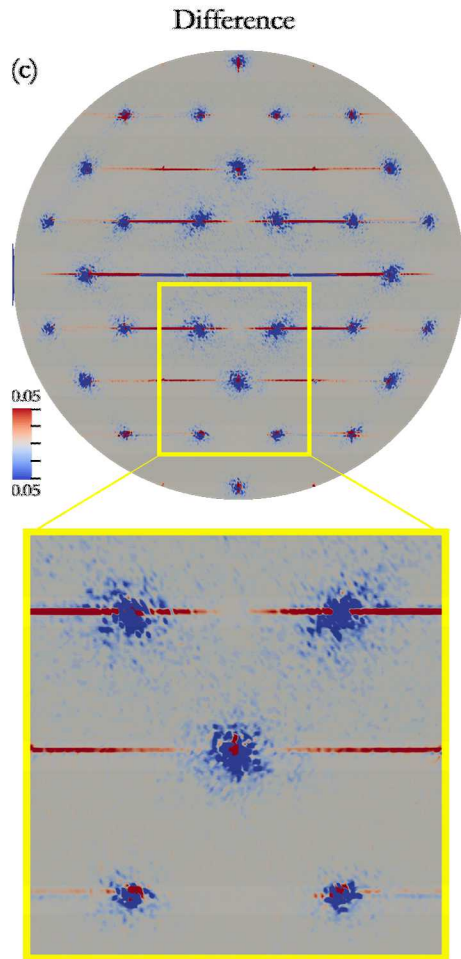
It is difficult to correlate real-space images with molecular dynamics modeling. Diffraction patterns can be used by both as a more reliable method of comparison.



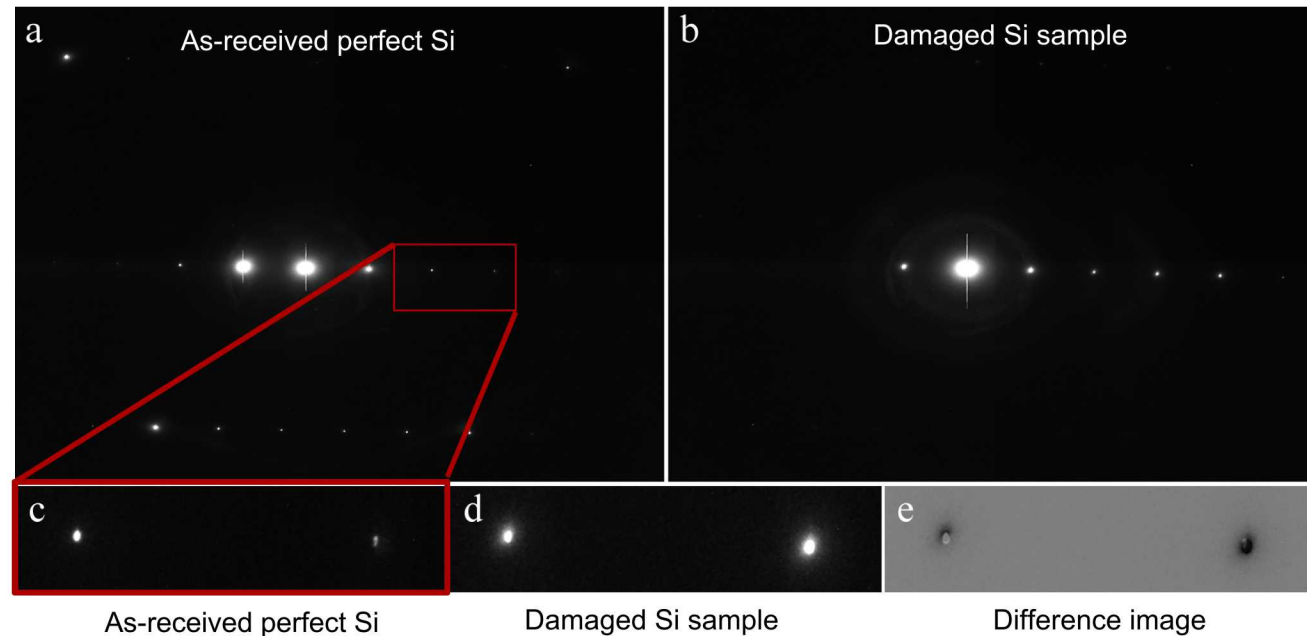
[Stewart et al. (2018) J. Appl. Phys.]

# Using Diffraction to Compare Modeling and Experiments

## Simulated Image



## Before and After In-Situ Irradiation



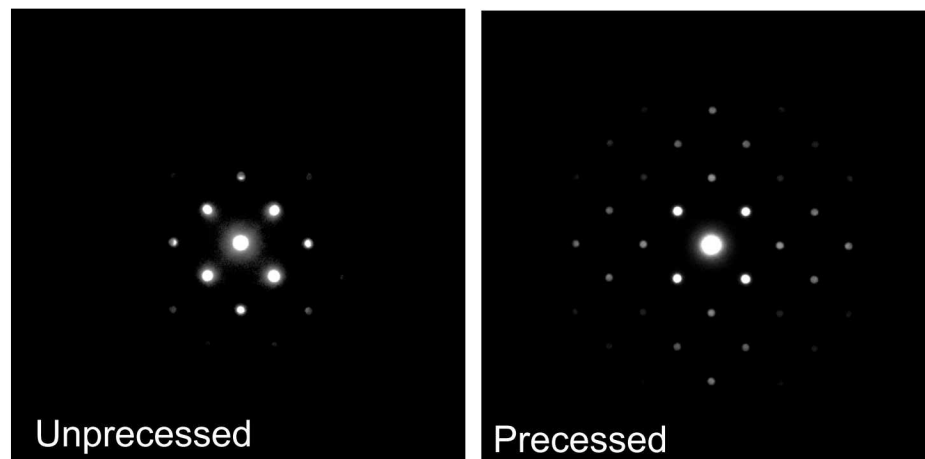
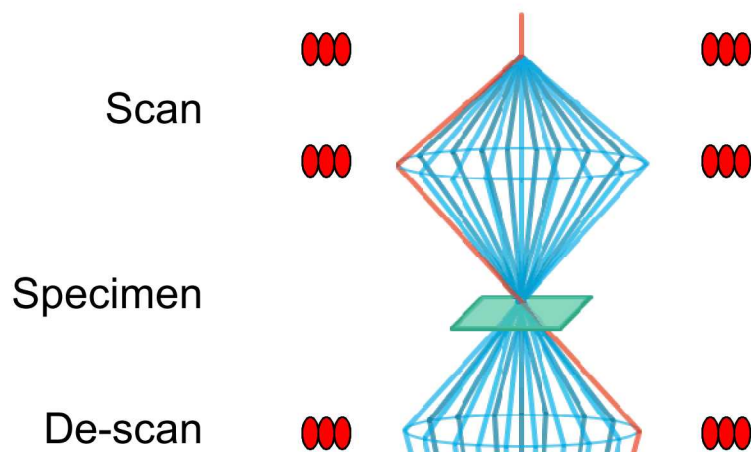
SAED may suggest a similar trend. However, many factors can influence diffraction spot size. **Precession electron diffraction (PED)**, may provide a more consistent pattern.

[Stewart et al. *J Appl. Phys.* (2018)]



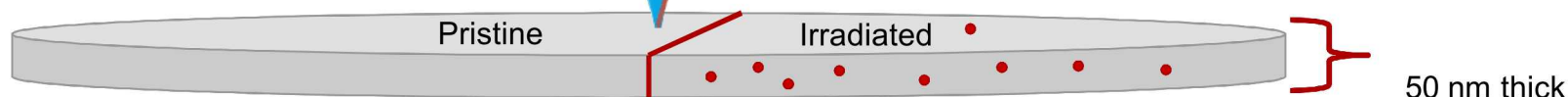
# Precession Electron Diffraction (PED) Microscopy

<001> Pristine Silicon



## Advantages for interpretation of radiation damage

- ~ 10 nm spatial resolution
- Near kinematical electron diffraction, allowing for interpretation of intensities
- Symmetry ambiguities are resolved



50 nm thick <001> Si irradiated with 46 keV Au<sup>+</sup> to a fluence ~10<sup>13</sup> ions/cm<sup>2</sup>. Samples were half irradiated so that each sample had a pristine and an irradiated region. The same exact imaging, precession, and camera conditions were used to capture patterns from each area.

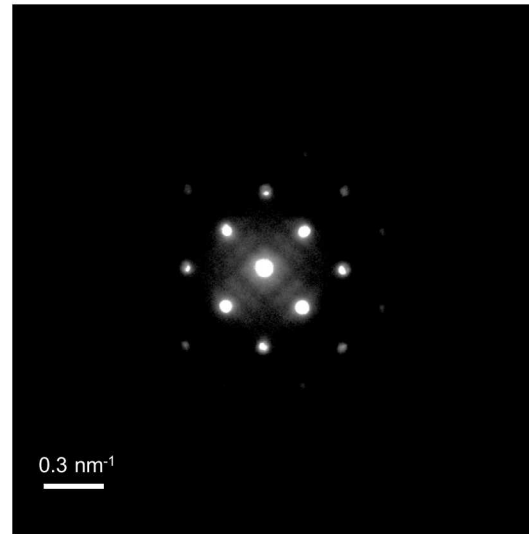
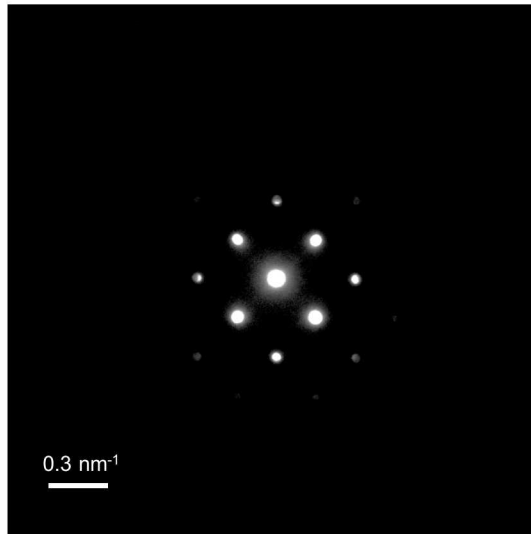
# Precession Electron Diffraction of Irradiated Silicon

Pristine

Irradiated

0°

Precession  
Angle

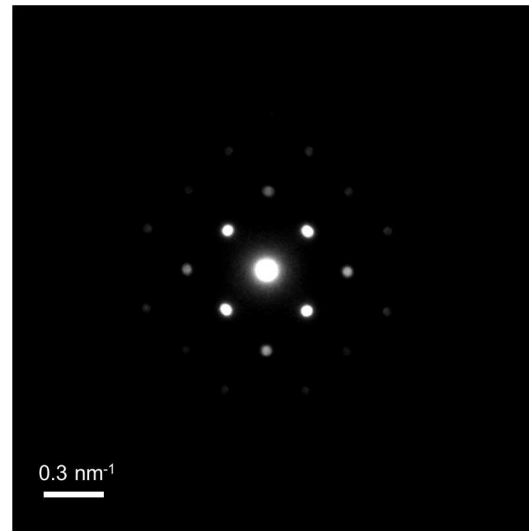
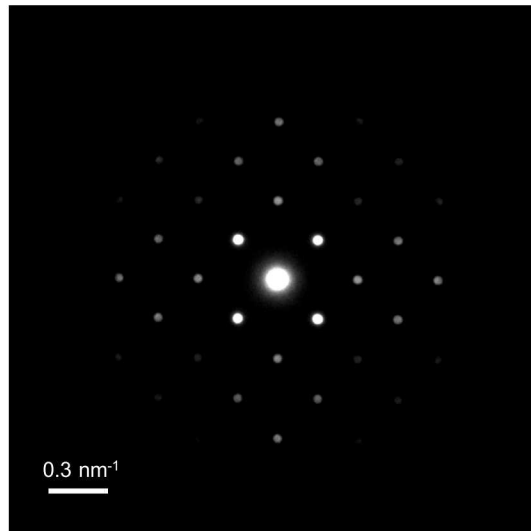


<001> Single Crystal Silicon  
irradiated to 10<sup>13</sup> ions/cm<sup>2</sup>  
with 46 keV Au<sup>+</sup>.

Precession patterns taken  
on pristine and irradiated  
sections of samples.

1.2°

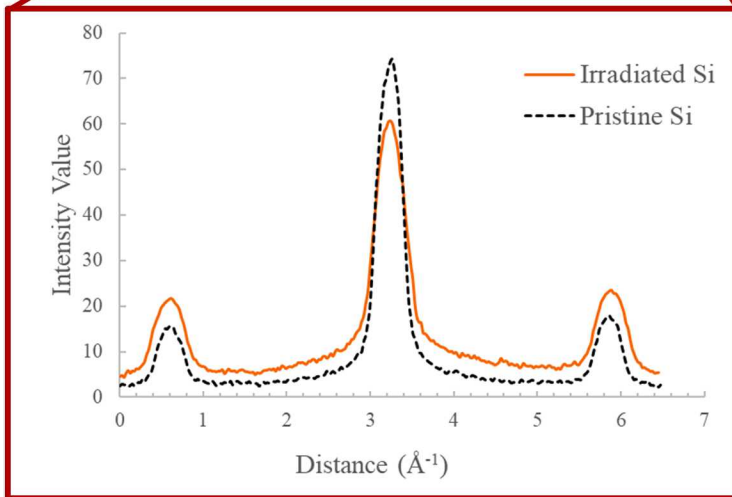
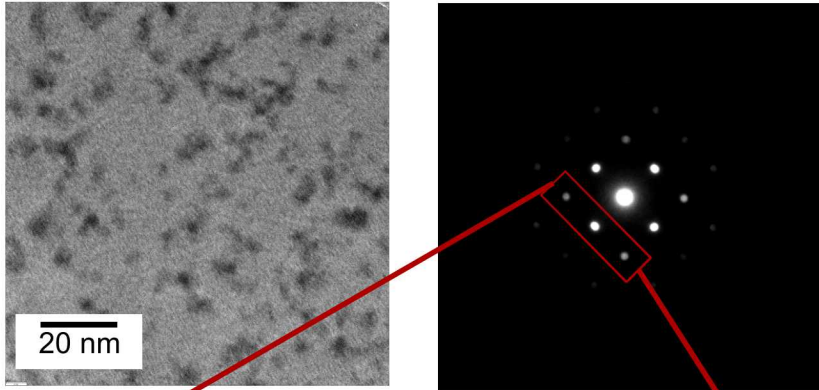
Precession  
Angle



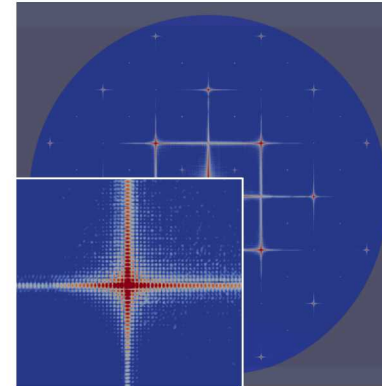
Precession spot size ~10 nm  
captured 2-3 black dot  
damage sites.

# PED Comparison with Simulation

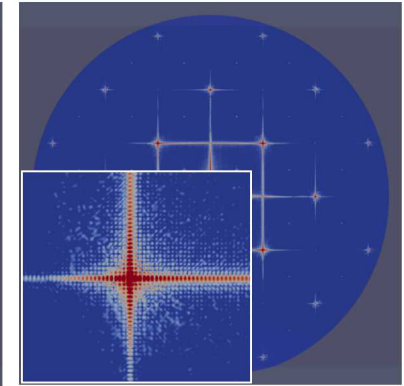
Experimental bright field and PED pattern of Irradiated Si



Simulated <001> Pristine Si



Simulated <001> Irradiated Si



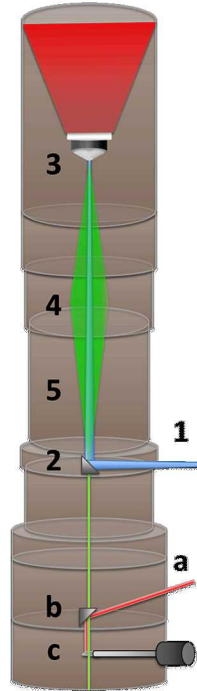
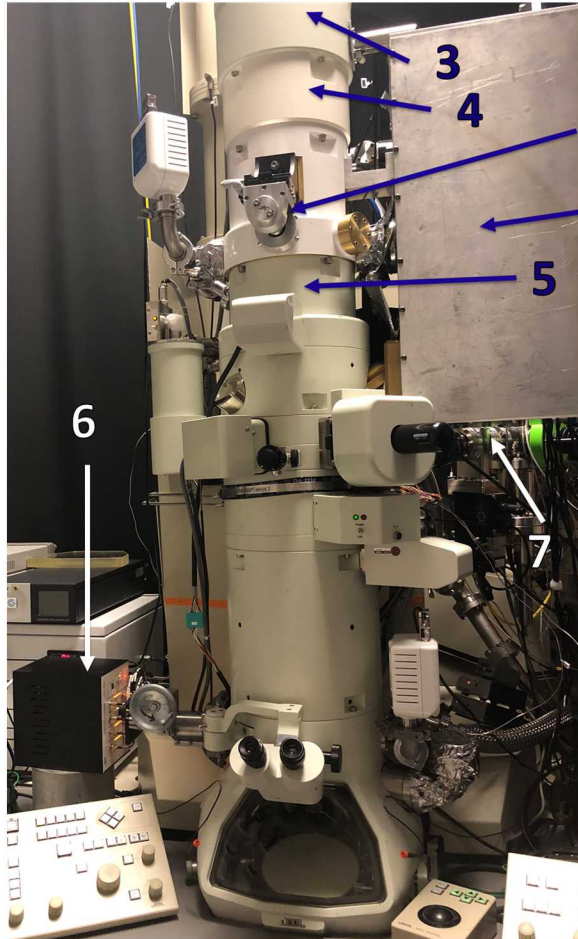
Simulations captured a single cascade within a 25 x 25 x 50 nm volume. Simulations were **not** preprocessed.

Radiation damage resulted in **broader and more diffuse diffraction spots** in both the experimental and simulated PED patterns.

Diffraction techniques can be used as a viable comparison. But **high temporal resolution is required** to probe evolution of the damage cascade.



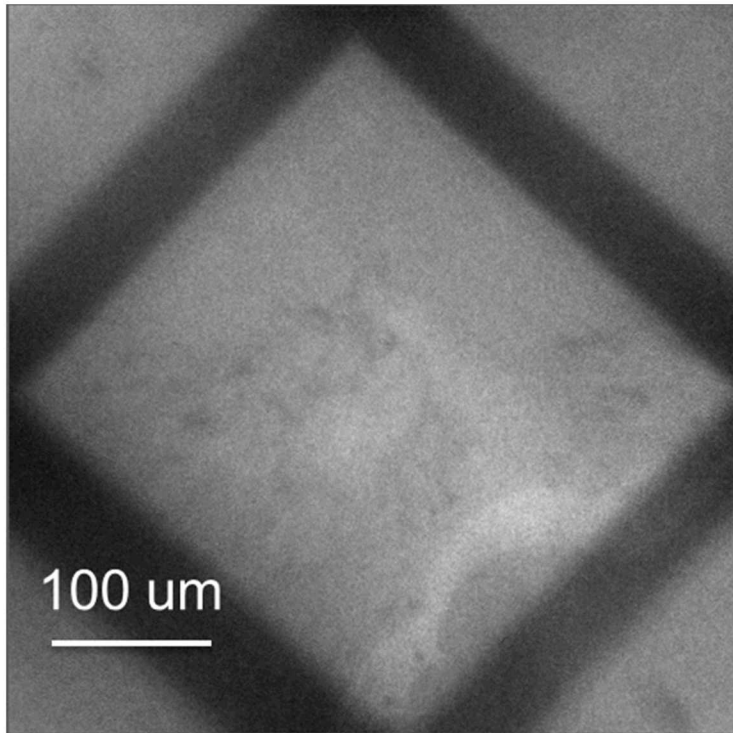
# Closing the Temporal Gap with Dynamic TEM (DTEM)



1. UV and IR laser optics system
2. Molybdenum mirror
3. Tantalum cathode
4.  $C_0$  lens
5. Drift section
6. Ultrafast deflector
7. Ion irradiation beamline

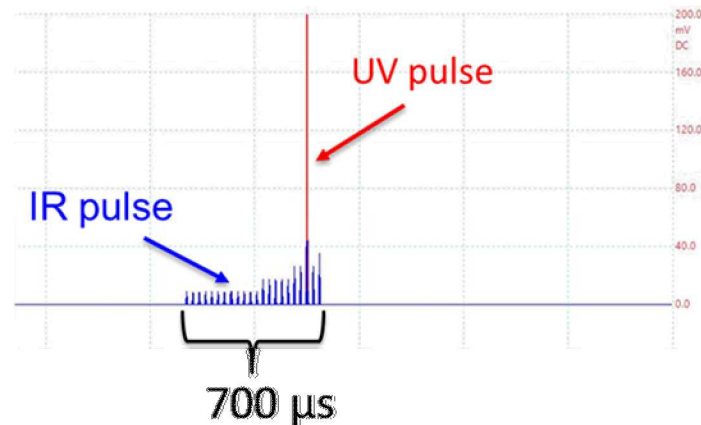
- Further modifications were added to the I<sup>3</sup>TEM converted to a Dynamic Transmission Electron Microscope (DTEM)
- UV laser is directed at a Ta cathode to photoexcite a nanosecond pulse of electrons
- IR laser is directed to the sample to incite a reaction
- Photoexcited electrons produce an image of the reaction occurring
- Conversion marks the **world's first in-situ ion irradiation dynamic transmission electron microscope (I<sup>3</sup>DTEM)!**

# Current State and Challenges for DTEM



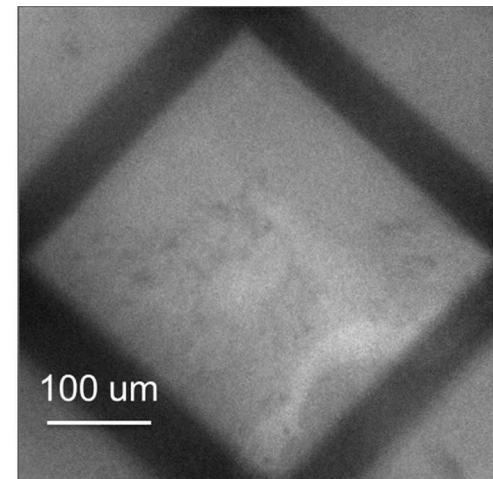
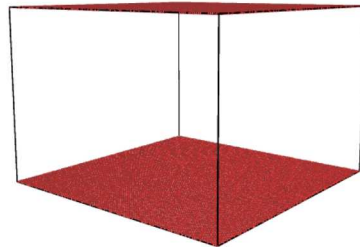
**Single Shot DTEM image of unreacted Al/Co multilayer sample**

- Successful photoemission and images obtained with DTEM
- Timing of IR and UV lasers determined
- UV and IR pulses can be triggered and timed with extreme precision to capture the events at the desired timing.
- Intensity needs to be increased to explore high magnification
- Timing between ion beam and UV laser for capture of single ion cascade needs to be determined



# Conclusions

- The **world's first in-situ ion irradiation dynamic transmission electron microscope (I<sup>3</sup>DTEM)** has been created at Sandia National Laboratories.
- This microscope allows for the study of processes/reactions occurring on the **nanosecond and nanometer scale**, including the study of single ion strikes.
- Radiation damage produces diffuse diffraction spots which can be probed by PED
- Future work and improvements:
  - Utilize higher resolution PED (using STEM)
  - Couple experimental PED with simulated PED
  - Increase in electron beam intensity for high magnification imaging
  - Synchronizing timing of UV laser with the capture of a single ion strike



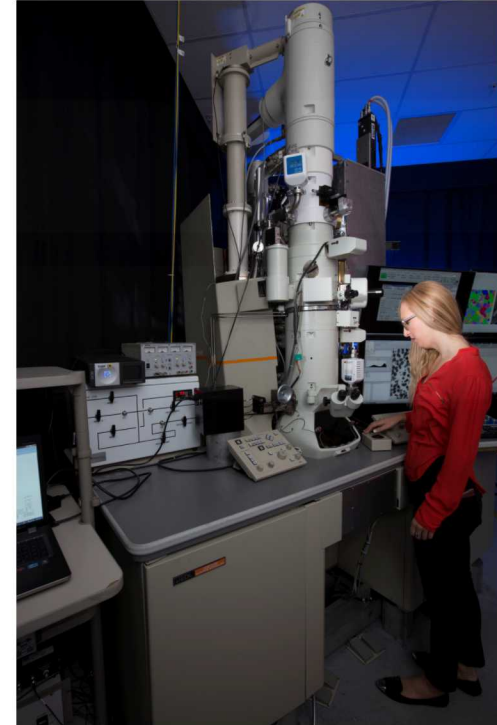




# QUESTIONS?

Anthony Monterrosa: [amonter@sandia.gov](mailto:amonter@sandia.gov)

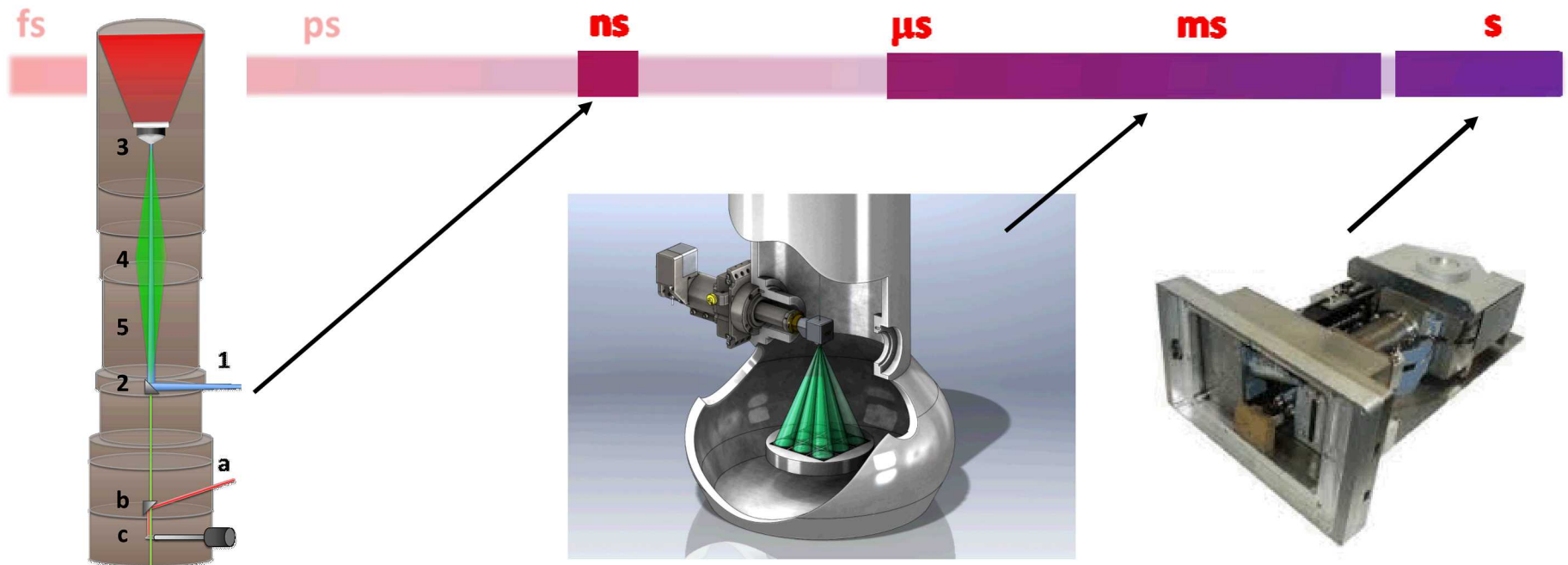
Khalid Hattar: [khattar@sandia.gov](mailto:khattar@sandia.gov)



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# Extra Slides

# Increasing Temporal Resolution



## ■ DTEM

- Laser induced photoemission of electrons is needed to achieve sufficient current density to produce an image
- Provides nanosecond imaging of irreversible process

## ■ Deflector System

- Multiple images acquired on single frame
- Microsecond imaging possible
- Virtually no missing data (nanosecond gaps)

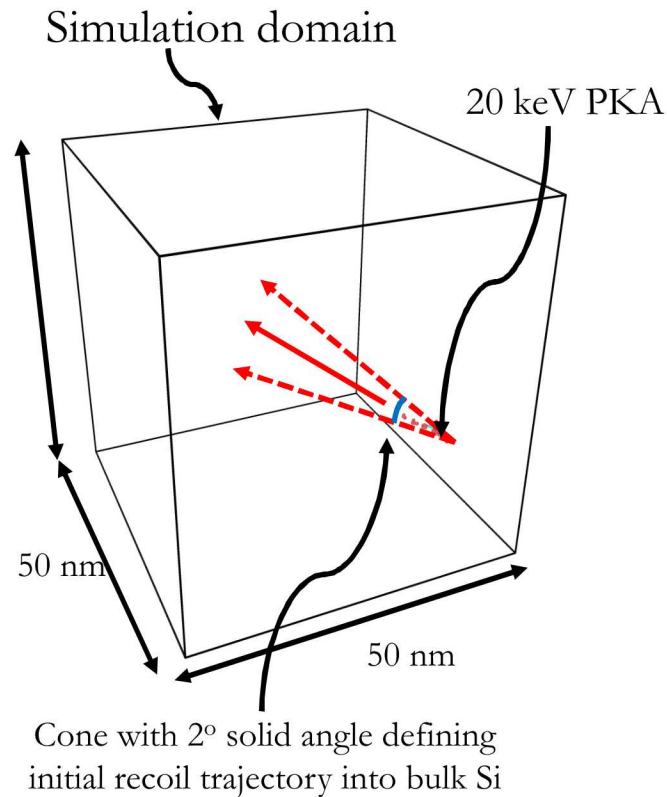
- Standard 1K TVIPS camera
  - Due to camera read out rate few images can be acquired
  - 10-20fps maximum
  - Missing data during camera readout



# CASCADE DAMAGE WITH MOLECULAR DYNAMICS SETUP



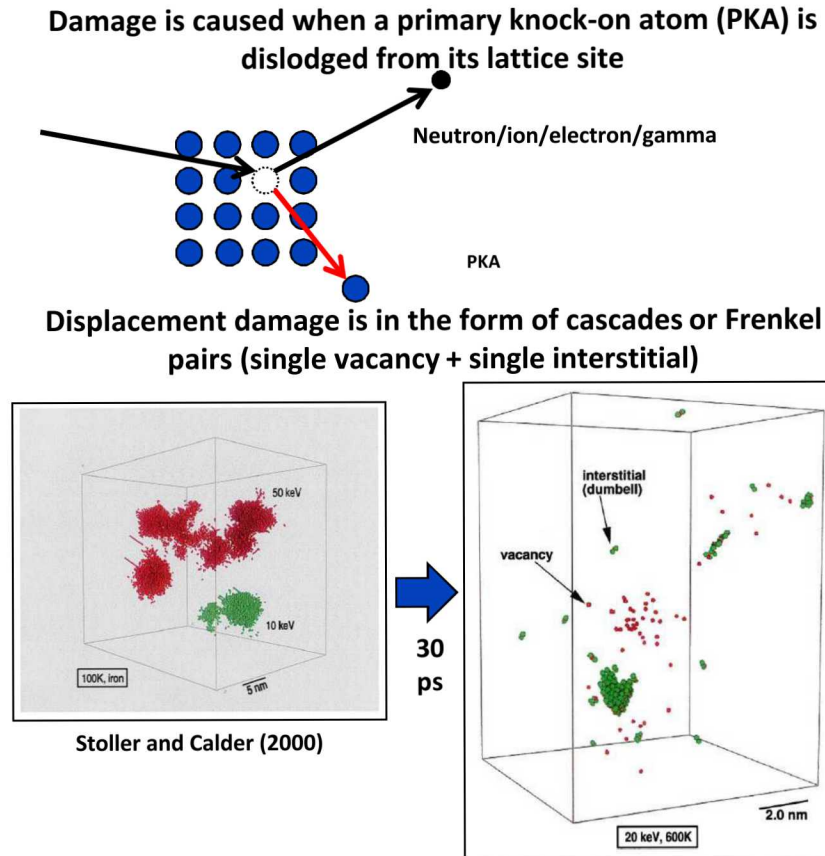
- LAMMPS code improved to perform simulation of PKA displacement cascade:
  - Improvement of electronic stopping effects (beyond SRIM)



# Computational Tools for Studying Radiation Damage

Tool Name	Uses
Density Functional Theory (DFT)	Defect binding and migration energies Developing atomic potentials
Atomistics: Molecular Dynamics (MD) and Molecular Statics (MS)	Cascade damage Defect binding and migration energies Defect interactions with other objects (dislocations, impurities)
Kinetic Monte Carlo methods: Object kinetic Monte Carlo (OKMC) Event kinetic Monte Carlo (EKMC) others	Cascade annealing Defect interactions with objects (dislocations, impurities) Sink strengths Defect accumulation Annealing
Rate theory methods: Mean field rate theory (MFRT) Cluster dynamics (CD)	Defect accumulation Annealing Large doses and times
Phase field models	Large-scale defect accumulation Bubble growth Interfacial behaviors
Discrete dislocation dynamics (DDD)	Defect-dislocation interactions Hardening

# How does Radiation Damage Occur?

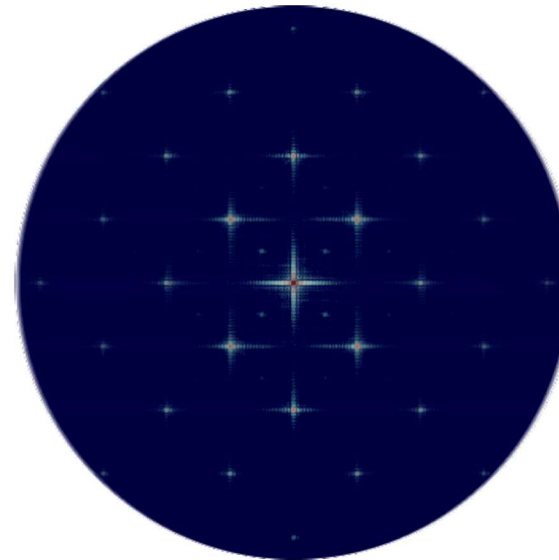
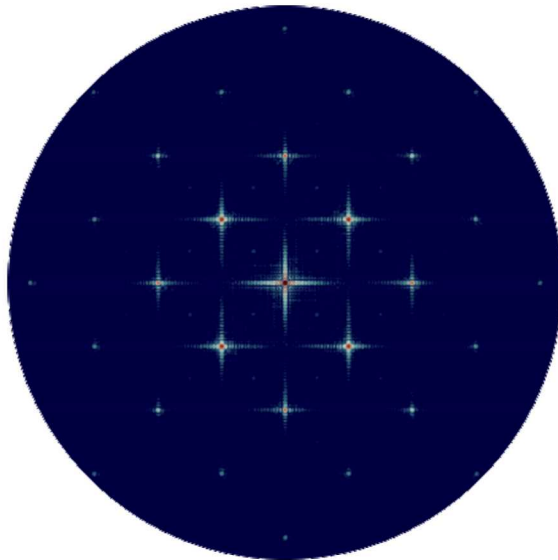


Source	Damage Type	Dose Rate (DPA/s)
Electron (1-3 MeV)	Frenkel Pair	$10^{-9} - 10^{-3}$
Neutron (1-14 MeV)	Cascade	$10^{-7} - 10^{-6}$ (fast fission, fusion) $10^{-12} - 10^{-11}$ (thermal fission)
Light ion (~10 keV)	Frenkel Pair	$10^{-4} - 10^{-2}$
Heavy ion (keV – MeV)	Cascade	$10^{-4} - 10^{-2}$
Gamma (>2 MeV)	Frenkel Pair	1-5 x neutron DPA rate (in HFIR)



# Preliminary Precession

[001]



Average of:  
[001]  
 $\overline{[0.04\ 0\ 1]}$   
 $\overline{[0.02\ 0\ 1]}$   
 $\overline{[0.02\ 0\ 1]}$   
 $\overline{[0.04\ 0\ 1]}$